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... apparatus 17 grasps the generation state of an alarm, and gives warning when the generation state reaches a predetermined **threshold**. Inventors: **Mori, Kazushi**; ...

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CONTROL SYSTEM, CONTROL METHOD, PROCESSING SYSTEM, COMPUTER READABLE STORING MEDIUM AND COMPUTER ...

K MORI - WO Patent WO/2006/016,436, 2006 - wipo.org

... Inventor: **MORI, Kazushi [JP/JP]**; c/o TOKYO ELECTRON KYUSHU LIMITED, 1375-41 ... generatingstatus, and when the status reaches a prescribed **threshold** value, the ...

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Surface emission semiconductor laser device - Google Patents

K Tominaga, K Mori, A Tajiri, Y Nomura, R Hiroyama - US Patent 6,967,985, 2005 - Google Patents

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Semiconductor device producing method, system for carrying out the same and semiconductor work ... - group of 3 »

M Noguchi, Y Kembo, H Morioka, H Nishiyama, H Doi, ... - US Patent 6,650,409, 2003 - Google Patents

... W 3 o teco r? "i - mo £ «= 2 <r - => < 2 0. NORMAL **CLEANING** CYCLE CLD> 0 ... 7 STOPPROCESSING THE LOT OR THE **WAFER** FIG. 8 ... 20 **ALARM GENERATION** CONTROL LIMIT Mq ...

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